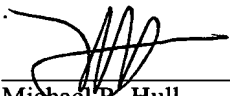




17W

**PATENT
30205/39513**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Young Sun Hwang et al.)	I hereby certify that this paper and the
)	documents referred to as enclosed
Serial No.: 10/719,083)	therewith are being deposited with the
)	United States Postal Service as first class
Filed: November 21, 2003)	mail, postage prepaid, on August 4, 2005,
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Photoresist Patterns)	P.O. Box 1450, Alexandria, Virginia
)	22313-1450
Group Art Unit: 1765)	
)	
Examiner: Patricia Ann George)	Michael R. Hull
)	Reg. No. 35,902
Confirmation No. 2261)	Attorney for Applicant
)	

RESPONSE TO RESTRICTION REQUIREMENT AND AMENDMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Commissioner:

In response to the restriction requirement imposed in the office action mailed on July 6, 2005, applicants elect Group I, claims 1-9, without traverse and submit the following amendment to clarify the claimed invention.

Amendments to the specification appear on page 2 of this paper.

Amendments to the claims and a complete listing of the claims begins on page 3 of this paper.

Remarks appear on page 4 of this paper.